



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: Confirmation No. 4076

Yoshiharu ANDA et al.

: Docket No. 2003_0955A

Serial No. 10/617,793

: Group Art Unit 2826

Filed July 14, 2003

: Examiner Tan N. Tran

SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of February 17, 2004, Applicants hereby elect Group I, which is drawn to a semiconductor device and is embodied by claims 1-6.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Yoshiharu ANDA et al.

By:

A handwritten signature in black ink, appearing to read "Michael S. Huppert".

Michael S. Huppert
Registration No. 40,268
Attorney for Applicants

MSH/kjf
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
March 11, 2004